

YOUNGJIN KIM

PhD Candidate

Seoul National University, Seoul, South Korea

Email	Linkedin	Website
ttw8592@snu.ac.kr	Click here	Click here

EDUCATION

B.S.	Electrical and Computer Engineering Seoul National University, Seoul, Republic of Korea Advisor: Byung Gook Park (deceased)	2012. 3 – 2019. 2
M.S. - Ph.D.	Electrical and Computer Engineering Seoul National University, Seoul, Republic of Korea Former advisor: Byoungcho Lee (deceased) Current advisor: Yoonchan Jeong (yoontan@snu.ac.kr)	2019.3 – 2024. 8 (expected)

RESEARCH INTERESTS

- Metasurfaces and flat optics
- Computational optics for imaging system and holographic display
- All-optical diffractive deep neural network

RESEARCH EXPERIENCE

- **Metasurfaces and flat optics**
 - Metasurface design using near-field and far-field simulations
 - Wafer double-side nanofabrication using lithography-techniques
 - Application to microscopic imaging system
 - Application to photographic camera module
- **Computational optics for imaging system and holographic display**
 - End-to-end optimization of metalens imaging system
 - Joint optimization of metasurface and computer-generated holograms (CGHs) for high-quality holographic display
 - Metasurface proxy model design for fully differentiable optimization framework
 - Metasurface blazed grating optimization through rigorous coupled-wave analysis
- **All-optical deep neural network**
 - Diffractive deep neural network design with multiple phase-only metasurfaces
 - Optical neural network platform design for visible photonics using double-side nanofabrication

SKILLS

Numerical simulations	Near-field simulations: RCWA (Python), FEM (COMSOL Multiphysics), FDTD (Lumerical)
	Far-field simulations: Ray-optic simulation (Zemax), Wave-optic simulation (MATLAB, Python)
	Programming languages & tools: MATLAB, Python (Pytorch), ZPL (for Zemax)
Experimental experiences	Optical microscopy, Photography, Holographic display with spatial light modulator, Laser/LED-based experiments
Device fabrication	Nanofabrication: Focused ion beam (FIB) milling, Electron beam lithography, Photolithography (Aligner, Maskless lithography), Electron beam evaporator, Plasma-enhanced chemical vapor deposition (PECVD), Reactive ion etching (RIE)
	Measurement: Scanning electron microscope (SEM), Ellipsometry
Languages	Korean (Native) / English (Fluent)

RESEARCH EXPERIENCE - *Projects*

- Metalens planar optic system for ultra-slim camera module**
 Researcher, Samsung Science & Technology Foundation
 Jun. 2020 – July. 2023
- Improvement of μ LED optical characteristics using metasurface technology.**
 Researcher, Samsung Display
 March. 2021 – Feb. 2023
- Research for integrated meta-photonics system and its application to mobile real-time 3D imaging**
 Researcher, National Research Foundation of Korea
 Mar. 2020 - November. 2022
- Development of virtual reality technology using metasurface optics**
 Researcher, Samsung Display
 March. 2020 – Feb. 2021

HONOR AND AWARDS

- Silver Prize, Samsung Display Industry-Academia Technical Paper Awards**
 Samsung Display, 2023.
- Scholarship of Foundation for SNU ECE - Kim Jung Sik Fund**
 Seoul National University, 2021.
- Best Poster Paper Awards**
 Optics and Photonics Congress, Jeju, South Korea, 2021.

JOURNAL PUBLICATIONS

First Author (2)

† : equal contribution

1. **Y. Kim**, G. -Y. Lee, J. Sung, J. Jang, and B. Lee, "[Spiral Metalens for Phase Contrast Imaging](#)," **Advanced Functional Materials**, vol. 32, no. 5, pp. 2106050, 2022.
2. S. -W. Nam[†], **Y. Kim[†]**, D. Kim, and Y. Jeong, "[Depolarized Holography with Polarization-multiplexing Metasurface](#)," **ACM Transactions on Graphics (SIGGRAPH Asia)**, vol. 42, no. 6, article 200, 2023.

JOURNAL PUBLICATIONS

Co-Author (2)

1. S.-J. Kim, C. Kim, **Y. Kim**, J. Jeong, S. Choi, W. Han, J. Kim, and B. Lee, "[Dielectric metalens: properties and three-dimensional imaging applications](#)," **Sensors**, vol. 21, no. 13, pp. 4584, 2021.
2. J. Jang, G. -Y. Lee, **Y. Kim**, C. Kim, Y. Jeong, and B. Lee, "[Dispersion-Engineered Metasurface Doublet Design for Broadband and Wide-Angle Operation in the Visible Range](#)," **IEEE Photonics Journal**, vol. 15, no. 4, pp. 1-9, 2023.

CONFERENCES

First Author (5)

1. **Y. Kim**, C. Kim, B. Lee, Y. Jeong, and B. Lee, "Meta-optic Miniaturized Telephoto Lens System," High Contrast Metastructures XII, SPIE Photonics West 2023, San Francisco, USA, paper 12432-32, Feb. 2023. **(Oral presentation)**
 2. **Y. Kim**, C. Kim, and B. Lee, "Phase contrast imaging with multiwavelength achromatic spiral metalens," OSA Optical Design and Fabrication Congress, Virtual Conference, paper FW4C.3, Jun. 2021. **(Oral presentation)**
 3. **Y. Kim**, J. Hong, and B. Lee, "Edge detection metalens with additional spiral phase profiles," The 20th International Meeting on Information Display (IMID 2020), Virtual Conference, paper 04-10-1232, Aug. 2020. **(Oral presentation)**
 4. **Y. Kim**, C. Kim, and B. Lee, "Single-layer edge detecting metalens with combining hyperbolic and spiral phase profiles," The 14th Pacific Rim Conference on Lasers and Electro-Optics (CLEO PR 2020), Virtual Conference, paper P5-7, Aug. 2020.
 5. **Y. J. Kim**, J. Hong, J. Sung, and B. Lee, "Transmission-Type Color Filters with Silicon Mie Resonators using Guided-Mode-Resonance," OSA Frontiers in Optics + Laser Science APS/DLS, Washington D.C., USA, paper JW4A.74, Sep. 2019.
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